



1725  
10/4/09  
H6 71

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Appln. Of: TANABE et al  
Serial No.: 09/612,551  
Filed: July 7, 2000  
For: SEMICONDUCTOR THIN FILM FORMING SYSTEM  
Group: 1725  
Examiner: G. Evans DOCKET: NEC WNZ-2212

Assistant Commissioner of Patents and Trademarks  
Washington, D.C. 20231

AMENDMENT A

Dear Sir:

In response to the Official Action mailed August 29, 2001, Applicants select Species I, and claim 1. It is respectfully requested that the remaining claims be maintained in the application, without further action thereon, for possible rejoinder.

In the event there are any fee deficiencies or additional fees are payable, please charge them (or credit any overpayment) to our deposit account number 08-1391.

RESPECTFULLY SUBMITTED

Norman P. Soloway  
Attorney for Applicants  
Registration No. 24,315

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Assistant Commissioner of Patents and Trademarks, Washington, D.C. 20231 on September 28, 2001, at Manchester, New Hampshire.

By Kristine Stevens

HAYES, SOLOWAY,  
HENNESSEY, GROSSMAN  
& HAGE, P.C.  
175 CANAL STREET  
MANCHESTER, NH  
03101-2335 U.S.A.

603-668-1400

RECEIVED  
OCT - 2001  
TECHNOLOGY CENTER 1700